

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Stefan F. Brouwer

Application No.: 10/549,963

Confirmation No.: 8316

Filed: August 3, 2006

Art Unit: 3632

Docket No. 65529-0006

Examiner: Ramon O. Ramirez

For: MIRROR SUPPORTING PLATE, MIRROR
ADJUSTING MECHANISM, METHOD FOR
MANUFACTURING A MIRROR SUPPORTING
PLATE, AND METHOD FOR ASSEMBLING A
MIRROR ADJUSTING MECHANISM

Commissioner for Patents
Mail Stop AF
Box 1450
Alexandria, VA 22313-1450

AMENDMENT PURSUANT TO 37 C.F.R. § 1.116

Dear Commissioner:

In response to the Office Action of March 14, 2008, please amend the above-identified application as follows.

Amendments to the Claims are reflected in the listing of claims which begin on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

A Request for Continued Examination (RCE) and a Request for an Extension of Time (one month) accompanies this submission.

CERTIFICATE OF TRANSMISSION

I hereby certify that this correspondence is, on the date shown below, being transmitted to the U.S. Patent and Trademark Office via the Office's electronic filing system EFS-Web addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: July 7, 2008

/Donna Crumit/
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